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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)					Application Number	10/721,979	
					Filing Date	11/25/2003	
					First Named Inventor	Shieh, et al.	
					Art Unit	2812	
				Examiner Name	TBD		
Shee	t ·	1	of	1	Attorney Docket Number	TSM02-1241	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	No.1	Number - Kind Code <sup>2 (Fknown)</sup>			
1	A	US-6,448,608 B1	09-10-2002	Pham, et al.	
m	В	US-6,559,501 B2	05-06-2003	Sung, et al.	
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		FOREIGI	N PATENT DOCU	MENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T°
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*  Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
02	С	OEHRLEIN, G.S., et al., "Surface Science Issues in Plasma Etching," [on-line] IBM Journal of Research and Development, Vol. 43, 1/2 (1999), Retrieved From: <a href="http://www.research.ibm.com/journal/rd/431/oehrlein.html">http://www.research.ibm.com/journal/rd/431/oehrlein.html</a>	
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Examiner	0 . 0 7	Date	/		
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Signature	of all Ollar	Considered	" 110104		

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